

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

251811US2

SERIAL NO.

10/822,816

LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Takeshi NANJYO, et al.

FILING DATE

April 13, 2004

GROUP

288+

AU 2873

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
45	AA	6,467,881	10/22/02	KATOH			
	AB	6,485,126	11/26/02	KATO et al.			
	AC	6,367,914	04/09/02	OHTAKA et al.			
	AD	6,312,108	11/06/01	KATO			
	AE	6,332,669	12/25/01	KATO et al.			
	AF	6,450,618	09/17/02	KATO et al.			
	AG	6,150,698	11/21/00	OHTSUKA et al.			
	AH	5,633,523	05/27/97	KATO			
	AI	5,811,353	09/22/98	NANJO			
	AJ	5,668,413	09/16/97	NANJO			
	AK	5,304,357	04/19/94	SATO et al.			
	AL	5,108,843	04/28/92	OHTAKA et al.			
	AM	5,017,987	05/21/91	NANJOH et al.			
45	AN	5,448,113	09/05/95	SUZUKI et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AO					
	AP					
	AQ					
	AR					
	AS					
	AT					
	AU					
	AV					

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

	AW		
	AX		
	AY		
	AZ		

☐ Additional References sheet(s) attached





Examiner

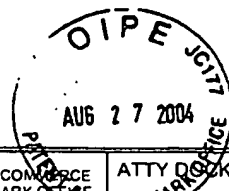
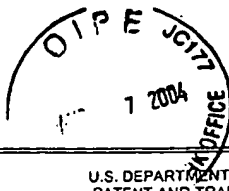
LOHA BEN

Date Considered

1/2/06

*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 251811US2		SERIAL NO. 10/822,816	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Takeshi NANJYO, et al.			
				FILING DATE April 13, 2004		GROUP 2881 AU 2873	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	5,408,113	04/18/95	KANNO et al.			
	AB	6,324,149	11/27/01	MIFUNE et al.			
	AC	6,636,368	10/21/03	OHTAKA			
	AD	6,710,949	03/23/04	OHTAKA			
	AE						
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FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW						
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	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner LOHA BEN				Date Considered 1/2/06			
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	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
LM	AL	2941952	06/18/1999	JAPAN (with WO 96/41224)			X
	AM	WO 96/41224	12/19/1996	WIPO			
	AN	3016871	12/24/1999	JAPAN (with corr. WO 96/41226)			X
	AO	WO 96/41226	12/19/1996	WIPO			
	AP	6-138403	05/20/1994	JAPAN (with English Abstract)			X
	AQ	2000-2842	01/07/2000	JAPAN (with English Abstract)			X
	AR	2002-131838	05/09/2002	JAPAN (with English Abstract)			X
	AS	5-2973	01/08/1993	JAPAN (with English Abstract)			X
LM	AT	8-84485	03/26/1996	JAPAN (with English Abstract)			X
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LM	AU	K. E. PETERSEN, Applied Physics Letters, vol. 31, no. 8, pages 521-523, "MICROMECHANICAL LIGHT MODULATOR ARRAY FABRICATED ON SILICON", October 15, 1977					
	AV	O. SOLGAARD, et al., Optics Letters, vol. 17, no. 9, pages 688-690, "DEFORMABLE GRATING OPTICAL MODULATOR", May 1, 1992					
	AW	L. J. HORNBECK, SPIE Critical Reviews Series, vol. 1150, pages 86-102, "DEFORMABLE-MIRROR SPATIAL LIGHT MODULATORS", 1989					
	AX	P. F. VAN KESSEL, et al., Proceedings of the IEEE, vol. 86, no. 8, pages 1687-1704, "A MEMS-BASED PROJECTION DISPLAY", August 1998					
	AY	D. S. DEWALD, Optical Engineering, vol. 39, no. 7, pages 1802-1807, "USING ZEMAX IMAGE ANALYSIS AND USER-DEFINED SURFACES FOR PROJECTION LENS DESIGN AND EVALUATION FOR DIGITAL LIGHT PROCESSING™ PROJECTION SYSTEMS", July 2000					
LM	AZ	O. BUTSURI, vol. 68, no. 3, pages 285-289, "DIGITAL MICRO-MIRROR DEVICE", 1999 (introduces the concepts of reference AX)				<input type="checkbox"/> Additional References sheet(s) attached	
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